

04-18-2000

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U.S. DEPARTMENT OF COMMERCE

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Patent and Trademark Office



101324069

To the Honorable Commissioner of Patents and Trademarks. Please record the attached original documents or copy thereof.

1. Name of conveying party(ies):

(a) Ho-Seob Kim

(b)

(c)

Additional name(s) of conveying party(ies) attached?

☐ Yes☒ No

2. Name and address of receiving party(ies):

Name: Etec Systems, Inc.Street Address: 26460 Corporate AvenueCity: Hayward State: California Zip: 94545Country: U.S.

3. Nature of Conveyance:

☒ Assignment☐ Merger☐ Security Agreement☐ Change of Name☐ Other _____Execution Date: 9/15/99

Name and address of receiving party(ies):

Name: _____

Street Address: _____

City: _____ State: _____ Zip: _____

Country: _____

4. Application number(s) or patent number(s):

If this document is being filed together with a new application, the execution date of the application is: _____

A. Patent Application No.(s) - 09/364,777

Title: Electrostatic Alignment Of A Charged Particle BeamFiled: July 30, 1999

B. Patent No.(s)

NA

Additional numbers attached? ☐ Yes ☒ No

5. Name and address of party to whom correspondence concerning document should be mailed:

Name: Michael J. HalbertInternal Address: SKJERVEN, MORRILL, MacPHERSON,FRANKLIN & FRIEL LLPStreet Address: 25 METRO DRIVE, SUITE 700City SAN JOSE State CA ZIP 951106. Total number of applications and patents involved: 1

7. Total fee (37 CFR 3.41):\$40.00

☒ Authorized to be charged to Deposit Account 19-2386☒ Charge Deposit Account 19-2386 for any additional fees required for this conveyance and credit deposit account 19-2386 any amounts overpaid

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8. Statement and signature.

To the best of my knowledge and belief, the foregoing information is true and correct and any attached copy is a true copy of the original document.

Michael J. Halbert Reg. No. 40,633

Name of Person Signing

Signature

3-7-00
Date

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Total number of pages comprising cover sheet 2

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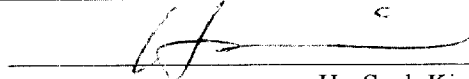
ASSIGNMENT

For good and valuable consideration, receipt of which is hereby acknowledged, I, Ho-Seob Kim, hereby sell, assign and transfer to Etec Systems, a Nevada corporation, having a place of business at 26460 Corporate Avenue, Hayward, California 94545, its successors and assigns, the entire right, title and interest throughout the world in my invention in

Electrostatic Alignment Of A Charged Particle Beam

for which I have filed a United States patent application on 07/30/99, and now has Serial No. 09/364,777, and all patent applications and patents of every country for said invention, including divisions, reissues, continuations and extensions thereof, and all rights of priority resulting from the filing of said applications; I authorize the above-named assignee to apply for patents of foreign countries for said invention, and to claim all rights of priority without further authorization from me; I agree to execute all papers useful in connection with said United States and foreign applications, and generally to do everything possible to aid said assignee, its successors, assigns and nominees, at their request and expense, in obtaining and enforcing patents for said invention in all countries; and I request the Commissioner of Patents and Trademarks to issue all patents granted for said invention to the above-named assignee, its successors and assigns.

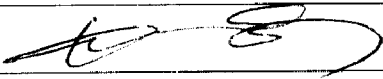
Executed this 5 day of September, 1999.



Ho-Seob Kim

WITNESSED:

Signature



Date

9/15/99

Type or print name of witness

Dae-Wook Kim